

RABIN & BERDO, P.C.

Specializing in Patent, Trademark
And Copyright Law

Suite 500, 1101 14" Street, N.W. Washington, D.C. 20005 Tel.: (202) 371-8976 Fax: (202) 408-0924 E-Mail: firm@rabinchamp.com

December 15, 2003

22386 U.S. PTO 10/734620

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC

Qixia Zhang, Pat. Agent (China)

Mail Stop Patent Application

Commissioner for Patents

P.O. Box 1450

Steven M. Rabin

Robert H. Berdo, Jr.

Phillip G. Avruch

Allen Wood

Alexandria, VA 22313-1450

Attorney Reference: MAE 303

Re: New Patent Application of: Mitsuhiko OGIHARA and Hiroyuki FUJIWARA

Title: SEMICONDUCTOR APPARATUS HAVING CONDUCTIVE LAYERS

AND SEMICONDUCTOR THIN FILMS

Sir:

Please find attached hereto an application for patent which includes:

- [x] Specification, Claims and Abstract (28 Pages)
- [x] 19 Sheets of Formal Drawings (Fig. 1 through Fig. 20)
- [x] Inventor's Declaration and Power of Attorney (2 Pages)
- [x] Assignment document with cover page (3 Pages)
- [x] Claim for priority and Priority document
- [x] Information Disclosure Statement, Form PTO-1449, and copy of 1 reference
- [x] Fee (see formula below)
- [x] Form PTO-2038

In the event there is attached hereto no check or form PTO-2038 (credit card payment form), or a check or form for an insufficient amount, please charge the fee or insufficiency to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2002-371769, filed December 24, 2002.

December 15, 2003

Date RHB:tl

Robert H. Berdo, Jr. (Reg. No. 38,075)

(Customer No. 23995)

Respectfully submitted

FEE ENCLOSED:\$2.76 Pl ase charge any furth fe to our Dep sit Acc un No. 18-0002